

EUV Lithography

By Vivek Bakshi

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Vivek Bakshi - Patents -

Vivek Bakshi patents Recent bibliographic sampling of Vivek Bakshi patents listed/published in the public domain by the USPTO (USPTO Patent Application #,Title):

<http://www.freshpatents.com/Vivek-Bakshi-Austin-invdirb.php>

EUV Lithography | (2008) | Bakshi | Publications -

Editorial Review. Dr. Bakshi has compiled a thorough, clear reference text covering the important fields of EUV lithography for high-volume manufacturing.

<http://spie.org/Publications/Book/769214>

EUV Lithography - Knovel -

Extreme ultraviolet lithography (EUVL) is the principal lithography technology aiming to manufacture computer chips beyond the current 193-nm-based optical

http://www.knovel.com/web/portal/browse/display?EXT_KNOVEL_DISPLAY_bookid=3504

Extreme Ultraviolet Lithography Still Beset by -

Jul 14, 2009 Extreme Ultraviolet Lithography Still The EUV lithography workshop is organized by Vivek Bakshi, EUV lithography has a history of delays and

<http://spectrum.ieee.org/semiconductors/devices/extreme-ultraviolet-lithography-still-beset-by-problems>

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CREOL, The College of Optics & Photonics at the -

EUV Sources for Lithography Ed: Vivek Bakshi, SPIE Press, volume Chapter 26, pages 687-718 2006. Simi George, Moza Al-Rabban, Kazutoshi Takenoshita, William

<http://www.creol.ucf.edu/People/AlumDetail.aspx?PeopleID=4387>

EUV Lithography - Data on AvaxHome -

Vivek Bakshi, "EUV Lithography" SP E Publications | 2008 | ISBN: 0819469645 | 702 pages | PDF | 41,4 MB

<http://avxsearch.se/?q=EUV%20Lithography>

EUV Sources for Lithography (SPIE Press Monograph -

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PM369)Vivek Bakshi (Editor) | SPIE Publications | 3133-13-33 | 3196 pages | English | PDFThis

<http://oovostew.blog.com/2012/01/20/euv-sources-for-lithography-spie-press-monograph-vol-pm149/>

EUV bet settled as source powers climb - -

EUV bet settled as source powers standing bet over EUV that was struck by Mack and EUV proponent Vivek Bakshi at the Advanced Lithography conference

<http://optics.org/news/6/2/32>

Blog: Moving forward with Moore's Law: Throughput -

Dr. Vivek Bakshi blogs about EUV Lithography (EUVL) and related topics of interest. He has edited two books on EUVL and is an internationally recognized expert on EUV

<http://electroiq.com/blog/2013/03/blog-moving-forward-with-moores-law-throughput-of-euvl-scanner/>

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<http://www.bokus.com/bok/9780819458452/euv-sources-for-lithography/>

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Extreme ultraviolet lithography (EUVL) is the principal lithography technology aiming to manufacture computer chips beyond the current 193-nm-based optical

<http://www.amazon.it/Euv-Lithography-Vivek-Bakshi/dp/0819469645>

Simulation and optimization of DPP hydrodynamics -

By Vivek Bakshi. Discharge produced plasma (DPP) devices are being used as a light source for Extreme Ultraviolet (EUV) Lithography.

http://www.academia.edu/7065963/Simulation_and_optimization_of_DPP_hydrodynamics_and_radiation_transport_for_EUV_lithography_devices

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<http://in.linkedin.com/pub/dir/vivek/bakshi>

Vivek Bakshi, Inventor, Austin, TX, US - -

Vivek Bakshi's Inventor profile, Austin, TX, US, INFINEON TECHNOLOGIES AG;SEMATECH, INC., 6 patents/applications from Jan 20, 2005 to Sep 04, 2007, 16 forward patent

<http://www.patentbuddy.com/Inventor/Bakshi-Vivek/11167718>

EUV Lithography - Vivek Bakshi - Bok -

Extreme ultraviolet lithography (EUVL) is the principal lithography technology aiming to manufacture computer chips beyond the current 193-nm-based optical

<http://www.bokus.com/bok/9780819469649/euv-lithography/>

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<http://kfjhgsdgs.dtn.ru/>

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<http://www.worldcat.org/title/euv-lithography/oclc/697174164>

EUV Litho, Inc. - EUV Lithography -

Instructors Dr. Vivek Bakshi (EUV Litho, Inc.), Dr. Jinho Ahn (Hanyang University) and Dr. Patrick Naulleau (LBNL) Date and Time Monday, June 23, 2014 (8:30 AM - 5 PM)

https://www.euvlitho.com/info_13

Vivek Bakshi | EUV Litho Inc | ZoomInfo.com -

View Vivek Bakshi's business profile as President at EUV Litho Inc and see work history, affiliations and more.

<http://www.zoominfo.com/p/Vivek-Bakshi/380117112>

SPIE | EUV Lithography -

Extreme ultraviolet lithography (EUVL) is the leading patterning technology for the production of computer chips beyond the current 193-nm-based optical lithography.

<http://ebooks.spiedigitallibrary.org/book.aspx?bookid=104>

SPIE | EUV Sources for Lithography -

Until recently, EUV source power was the number one challenge to implementing EUV lithography (EUVL) in the high-volume manufacturing of computer chips.

<http://ebooks.spiedigitallibrary.org/book.aspx?bookid=124>

EUVL Focus Blog Archive EUV Lithography What -

EUV Lithography What is Next and When? By Vivek Bakshi, EUV Litho, Inc. This year started with an announcement, during the SPIE AL Conference, of the

<http://semimd.com/euvl-focus/2015/06/08/euv-lithography-what-is-next-and-when/>

Dynamic Simulation of Discharge and Laser Produced -

Dynamic Simulation of Discharge and Laser Produced Plasma for EUV Lithography Devices. Added by Vivek Bakshi. Vivek Bakshi hasn't uploaded this paper.

http://www.academia.edu/7065965/Dynamic_Simulation_of_Discharge_and_Laser_Produced_Plasma_for_EUV_Lithography_Devices

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<http://www.ebay.com.au/itm/EUV-Lithography-Vivek-Bakshi-/311395689670>

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<http://www.barnesandnoble.com/c/vivek-bakshi>

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SPIE Profile : Dr. Vivek Bakshi - EUV Litho Inc - Regular Member - the International Society for Optics and Photonics.
<http://spie.org/profile/Vivek.Bakshi-45578>

Vivek Bakshi - Academia.edu -

Vivek Bakshi studies Optics, Extreme ultraviolet lithography (EUVL) Join Vivek and 23,440,070 other researchers on Academia.edu.
<http://independent.academia.edu/VBakshi>

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EUV Lithography [Vivek Bakshi] on Amazon.com. *FREE* shipping on qualifying offers. EUVL is an area of intense research and this book provides the foundation required
<http://www.amazon.com/EUV-Lithography-Vivek-Bakshi/dp/0470471557>

Books: EUV Sources for Lithography (SPIE Press -

Author: Vivek Bakshi (Editor), Title: EUV Sources for Lithography (SPIE Press Monograph Vol. PM149) (Hardcover), Publisher: SPIE Publications, Category: Books, ISBN
<http://www.tower.com/euv-sources-for-lithography-vivek-bakshi-hardcover/wapi/101021938>

2015 SPIE Advanced Lithography EUVL Conference -

By Vivek Bakshi, EUV Litho, Inc. The SPIE AL EUVL Conference was held from February 22-26, 2015 in San Jose, CA. The atmosphere in this year s EUVL Conference was
<http://electroiq.com/euvl-focus/2015/03/10/2015-spie-advanced-lithography-euvl-conference-summary-and-analysis/>

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Extreme Ultraviolet Lithography (Editors: Vivek Bakshi and Anthony Yen) (Link) SPIE December 2012. An SPIE Special Collection In the drive to maintain scaling of
<https://www.linkedin.com/pub/vivek-bakshi/1/6a5/73a>

EUV Lithography for Higher Power - Semiconductor -

EUV sources achieve higher power, but need greater collector lifetimes, writes Vivek Bakshi of SEMATECH's technical staff.
<http://www.semiconductor-technology.com/features/feature215/>